

| L Number | Hits | Search Text | DB | Time stamp |
|----------|------|--|-------|------------------|
| - | 67 | datum near platen | USPAT | 2003/08/08 15:21 |
| - | 1 | ((datum near platen) and wafer | USPAT | 2002/11/05 13:49 |
| - | 1873 | ((standard reference calibrat\$3) near wafer | USPAT | 2002/11/05 13:49 |
| - | 0 | ((standard reference calibrat\$3) near wafer) near slice | USPAT | 2002/11/05 13:50 |
| - | 0 | ((standard reference calibrat\$3) near wafer) near strip | USPAT | 2002/11/05 13:50 |
| - | 4 | ((standard reference calibrat\$3) near wafer) near thin | USPAT | 2002/11/05 13:50 |
| - | 201 | ((359/509).CCLS. | USPAT | 2002/11/05 14:06 |
| - | 4 | ((359/509).CCLS.) and venturi | USPAT | 2002/11/05 14:07 |
| - | 320 | venturi and wafer | USPAT | 2002/11/05 14:08 |
| - | 1 | ("6218320").PN. | USPAT | 2003/03/07 15:44 |
| - | 1 | ("5503875").PN. | USPAT | 2003/03/07 15:44 |
| - | 1 | ("5679165").PN. | USPAT | 2003/03/07 15:45 |
| - | 1 | ("6495805").PN. | USPAT | 2003/03/07 15:47 |
| - | 4 | ((("6218320").PN.) (("5503875").PN.) ("5679165").PN.) ("6495805").PN.) | USPAT | 2003/03/07 15:45 |
| - | 0 | ((("6218320").PN.) (("5503875").PN.) ("5679165").PN.) ("6495805").PN.) and (lens window) | USPAT | 2003/03/07 15:45 |
| - | 32 | ((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN. | USPAT | 2003/03/07 15:49 |
| - | 12 | ((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN. | USPAT | 2003/03/07 15:49 |
| - | 44 | ((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) ((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.) | USPAT | 2003/03/07 15:49 |

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| - | 17 | ((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) ((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens window) | USPAT | 2003/03/07 15:54 |
| - | 7 | ((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) ((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens window)) and valve | USPAT | 2003/03/07 15:51 |
| - | 7 | ((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) ((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens window)) and valve) and gas | USPAT | 2003/03/07 15:51 |

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| - | 5 | ((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) ((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens) | USPAT | 2003/03/07 15:54 |
| - | 2 | ((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) ((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens)) and valve | USPAT | 2003/03/07 15:54 |
| - | 2 | ((("5851842") or ("6051844") or ("4602981") or ("5254367") or ("5336356") or ("5478455") or ("5534359") or ("5578504") or ("5578505") or ("5665214") or ("5665905") or ("5693178") or ("5755877") or ("5789734") or ("5818596") or ("5841110") or ("5899702") or ("5953578") or ("5955139") or ("5960255") or ("5994676") or ("6030887") or ("6083833") or ("6086734") or ("6121622") or ("6123766") or ("6131052") or ("6136712") or ("6147020") or ("6159388") or ("6211094") or ("6218264") or ("6211094")).PN.) ((("6250914") or ("6267158") or ("6331890") or ("6414280") or ("6435869") or ("6451674") or ("6472639") or ("6495805") or ("4383907") or ("5273424") or ("5421190") or ("5552888")).PN.)) and (lens)) and valve | USPAT | 2003/03/07 15:54 |
| - | 7908 | deposition near chamber | USPAT; US-PGPUB | 2003/03/27 13:00 |
| - | 64 | (deposition near chamber) same lens | USPAT; US-PGPUB | 2003/03/27 13:05 |
| - | 0 | ((deposition near chamber) same lens) and (datum near platen) | USPAT; US-PGPUB | 2003/03/27 13:05 |
| - | 0 | (datum near platen) and (deposition near chamber) | USPAT; US-PGPUB | 2003/03/27 13:05 |
| - | 79 | datum near platen | USPAT; US-PGPUB | 2003/03/27 13:06 |
| - | 13 | (datum near platen) and (wafer semiconductor) | USPAT; US-PGPUB | 2003/03/27 13:07 |

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|---|------|---|--------------------|---------------------|
| - | 238 | (deposition near chamber) and platen | USPAT; US-PGPUB | 2003/03/27 13:07 |
| - | 30 | ((deposition near chamber) and platen) and lens | USPAT; US-PGPUB | 2003/03/27 13:08 |
| - | 5 | cdv and (lens same (housing chamber)) | USPAT; US-PGPUB | 2003/08/07 22:07 |
| - | 892 | cdv and (lens same (housing chamber)) | USPAT; US-PGPUB | 2003/08/07 22:00 |
| - | 193 | (cdv and (lens same (housing chamber))) and (inert and nitrogen) | USPAT; US-PGPUB | 2003/08/07 22:07 |
| - | 0 | ((cdv and (lens same (housing chamber))) and (inert and nitrogen)) and venturi | USPAT; US-PGPUB | 2003/08/07 22:00 |
| - | 0 | (cdv and (lens same (housing chamber))) and venturi | USPAT; US-PGPUB | 2003/08/07 22:00 |
| - | 191 | cdv and venturi | USPAT; US-PGPUB | 2003/08/07 22:01 |
| - | 77 | (cdv and venturi) and (venturi same vacuum) | USPAT; US-PGPUB | 2003/08/07 22:01 |
| - | 169 | ((cdv and (lens same (housing chamber))) and (inert and nitrogen)) and vacuum | USPAT; US-PGPUB | 2003/08/07 22:01 |
| - | 246 | ((cdv and venturi) and (venturi same vacuum)) ((cdv and (lens same (housing chamber))) and (inert and nitrogen)) and vacuum) | USPAT; US-PGPUB | 2003/08/07 22:02 |
| - | 48 | ((cdv and venturi) and (venturi same vacuum)) ((cdv and (lens same (housing chamber))) and (inert and nitrogen)) and vacuum)) and (nozzle and valve) | USPAT; US-PGPUB | 2003/08/07 22:02 |
| - | 17 | ((cdv and venturi) and (venturi same vacuum)) ((cdv and (lens same (housing chamber))) and (inert and nitrogen)) and vacuum)) and (nozzle and valve)) and (platen platform stage support) same (reference standard\$ datum)) | USPAT; US-PGPUB | 2003/08/07 22:09 |
| - | 6578 | (semiconductor wafer) and (lens same (housing chamber)) | USPAT; US-PGPUB | 2003/08/07 22:07 |
| - | 516 | ((semiconductor wafer) and (lens same (housing chamber))) and (inert and nitrogen) | USPAT; US-PGPUB | 2003/08/07 22:08 |
| - | 3 | ((semiconductor wafer) and (lens same (housing chamber))) and (inert and nitrogen)) and venturi | USPAT; US-PGPUB | 2003/08/07 22:08 |
| - | 211 | ((semiconductor wafer) and (lens same (housing chamber))) and (inert and nitrogen)) and ((platen platform stage support) same (reference standard\$ datum)) | USPAT; US-PGPUB | 2003/08/07 22:09 |
| - | 42 | ((semiconductor wafer) and (lens same (housing chamber))) and (inert and nitrogen)) and ((platen platform stage support) same (reference standard\$ datum))) and (vacuum and nozzle) | USPAT; US-PGPUB | 2003/08/07 22:09 |
| - | 35 | ((semiconductor wafer) and (lens same (housing chamber))) and (inert and nitrogen)) and ((platen platform stage support) same (reference standard\$ datum))) and (vacuum and nozzle)) and valve | USPAT; US-PGPUB | 2003/08/07 22:09 |
| - | 6 | 5360980.URPN. | USPAT | 2003/08/07 22:15 |
| - | 4 | ("3986023" "4752131" "5083865" "5153671").PN. | USPAT | 2003/08/07 22:16 |
| - | 20 | 5083865.URPN. | USPAT | 2003/08/07 22:18 |
| - | 212 | (359/509).CCLS. | USPAT; US-PGPUB | 2003/08/08 15:21 |
| - | 140 | (250/431,428).CCLS. | USPAT; US-PGPUB | 2003/08/08 15:21 |
| - | 446 | (356/36).CCLS. | USPAT; US-PGPUB | 2003/08/08 15:21 |

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|---|------|---|--------------------|---------------------|
| - | 400 | (156/345.12,345.13,345.15).CCLS. | USPAT; US-PGPUB | 2003/08/08 15:22 |
| - | 1196 | ((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.) ((156/345.12,345.13,345.15).CCLS.) | USPAT; US-PGPUB | 2003/08/10 20:38 |
| - | 8 | ((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.) ((156/345.12,345.13,345.15).CCLS.)) and ((cvp cmp polish\$ etch\$) and (lens same (housing chamber))) | USPAT; US-PGPUB | 2003/08/08 15:24 |
| - | 5807 | ((cvp cmp polish\$ etch\$) and (lens same (housing chamber))) | USPAT; US-PGPUB | 2003/08/10 20:50 |
| - | 92 | ((cvp cmp polish\$ etch\$) and (lens same (housing chamber))) and ((standard reference calibra\$) near (slice wafer substrate)) | USPAT; US-PGPUB | 2003/08/08 16:21 |
| - | 8 | (((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate))) and (nitrogen and inert) | USPAT; US-PGPUB | 2003/08/08 15:25 |
| - | 16 | ((cvp cmp polish\$ etch\$) and (lens same (housing chamber))) and venturi | USPAT; US-PGPUB | 2003/08/08 16:22 |
| - | 92 | ((cvp cmp polish\$ etch\$) and (lens same (housing chamber))) and ((standard reference calibra\$) near (slice wafer substrate)) | USPAT; US-PGPUB | 2003/08/08 16:22 |
| - | 16 | ((cvp cmp polish\$ etch\$) and (lens same (housing chamber))) and venturi | USPAT; US-PGPUB | 2003/08/08 16:22 |
| - | 108 | (((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate)))) (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi) | USPAT; US-PGPUB | 2003/08/08 16:23 |
| - | 92 | (((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate)))) (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi) and (inert nitrogen nozzle valve vacuum) | USPAT; US-PGPUB | 2003/08/08 16:27 |
| - | 25 | (((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate)))) (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi) and ((inert nitrogen) and (nozzle valve vacuum)) | USPAT; US-PGPUB | 2003/08/08 16:24 |
| - | 67 | (((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate)))) (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi) and (inert nitrogen nozzle valve vacuum)) not ((((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((standard reference calibra\$) near (slice wafer substrate)))) (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and venturi) and ((inert nitrogen) and (nozzle valve vacuum))) | USPAT; US-PGPUB | 2003/08/08 16:27 |
| - | 723 | (cvp cmp polish\$3 etch\$3) and (dummy near (holder stage platform platen wafer)) | USPAT; US-PGPUB | 2003/08/10 20:41 |
| - | 1196 | ((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.) ((156/345.12,345.13,345.15).CCLS.) | USPAT; US-PGPUB | 2003/08/10 20:38 |

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|---|------|--|--------------------|---------------------|
| - | 6 | ((cvp cmp polish\$3 etch\$3) and (dummy near (holder stage platform platen wafer))) and (((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.) ((156/345.12,345.13,345.15).CCLS.)) | USPAT; US-PGPUB | 2003/08/10 20:38 |
| - | 23 | ((cvp cmp polish\$3 etch\$3) and (dummy near (holder stage platform platen wafer))) and (lens same (housing chamber)) | USPAT; US-PGPUB | 2003/08/10 20:42 |
| - | 23 | ((((cvp cmp polish\$3 etch\$3) and (dummy near (holder stage platform platen wafer))) and (lens same (housing chamber))) not (((cvp cmp polish\$3 etch\$3) and (dummy near (holder stage platform platen wafer))) and (((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.) ((156/345.12,345.13,345.15).CCLS.))) | USPAT; US-PGPUB | 2003/08/10 20:42 |
| - | 5807 | ((cvp cmp polish\$ etch\$) and (lens same (housing chamber))) | USPAT; US-PGPUB | 2003/08/10 20:51 |
| - | 672 | ((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) | USPAT; US-PGPUB | 2003/08/10 20:52 |
| - | 1 | ((((359/509).CCLS.) ((250/431,428).CCLS.) ((356/36).CCLS.) ((156/345.12,345.13,345.15).CCLS.)) and (((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) | USPAT; US-PGPUB | 2003/08/10 20:53 |
| - | 242 | (((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) and (nitrogen inert) | USPAT; US-PGPUB | 2003/08/10 20:53 |
| - | 160 | (((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) and (nitrogen inert)) and (extract\$ exhaust) | USPAT; US-PGPUB | 2003/08/10 20:53 |
| - | 56 | (((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) and (nitrogen inert)) and (extract\$ exhaust)) and nozzle | USPAT; US-PGPUB | 2003/08/10 20:55 |
| - | 51 | (((((cvp cmp polish\$ etch\$) and (lens same (housing chamber)))) and ((first second\$3 primary another other two) near (platen platform stage support chuck))) and (nitrogen inert)) and (extract\$ exhaust)) and nozzle) and valve | USPAT; US-PGPUB | 2003/08/10 20:55 |